



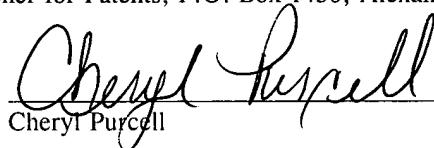
DOCKET NO: VSEA 07-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: George Gammel et al.
Serial No: 10/005,592
Confirmation No: 8123
Filed: October 26, 2001
For: ION IMPLANTATION SYSTEMS AND METHODS UTILIZING
A DOWN STREAM GAS SOURCE
Examiner: Jack I. Berman
Art Unit: 2881

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 1st day of September, 2004.



Cheryl Purcell

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petition for Extension of Time

A three-month extension of time to September 7, 2004 (Tuesday after holiday) is requested for response to the Examiner's Office Action of March 5, 2004.

The extension fee of \$950.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

Respectfully submitted,
George Gammel et al., Applicants

By: 

Mark A. Superko, Reg. No. 34,027
Varian Semiconductor Equipment
Associates, Inc.
35 Dory Rd.
Gloucester, Massachusetts 01930-2297
Telephone: (978) 282-5915

09/09/2004 ZJUHAR1 00000070 500896 10005592
01 FC:1253 950.00 DA

Docket No. VSEA 07-00